



TFW

PATENT  
Customer No. 22,852  
Attorney Docket No. 03180.0278

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                             |   |                               |
|-----------------------------|---|-------------------------------|
| In re Application of:       | ) |                               |
|                             | ) |                               |
| Ryoichi INANAMI et al.      | ) | Group Art Unit: 2881          |
|                             | ) |                               |
| Application No.: 09/817,270 | ) | Examiner: Phillip A. Johnston |
|                             | ) |                               |
| Filed: March 27, 2001       | ) |                               |
|                             | ) |                               |
| For: EXPOSURE PATTERN DATA  | ) | Confirmation No.: 7690        |
| GENERATION APPARATUS        | ) |                               |
| ASSOCIATED WITH STANDARD    | ) |                               |
| CELL LIBRARY AND CHARGED    | ) |                               |
| BEAM EXPOSURE               | ) |                               |

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION**

In reply to the Office Action mailed December 22, 2005, the period for response to which extends through March 22, 2006, Applicants request reconsideration and reexamination of the above-identified application based on the following remarks.

**Remarks** begin on page 2 of this paper.